

04/02/2008 15:16 9885266977

HORST M KASPER

PAGE 01/02

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Karola Richter et al.

Serial No: 10/553,728

Art Unit: 1765

Filing Date: October 14, 2005

Title: SILICON SUBSTRATE COMPRISING POSITIVE ETCHING  
PROFILES WITH A DEFINED SLOPE ANGLE AND PRODUCTION  
METHOD

Examiner: Patricia Ann George

April 2, 2008

Attorney's Docket No.: HMP201T1

## TRANSMITTAL LETTER

FAX NO. 571 273 1462

Hon. Commissioner of Patents

P.O. Box 1450,

Alexandria VA 22313

SIR:

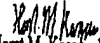
Transmitted herewith for filing is:

&lt;X&gt; EXPRESS ABANDONMENT dated April 2, 2008

&lt;X&gt; The Commissioner is hereby authorized to charge any fees under 35 U.S.C. 1.16, 1.17 and 1.18 or any additional fees which may be required during the entire pendency of the application, or credit any overpayment, to Acct. No.11-0224. A duplicate copy of this sheet is enclosed. If and only if(r) account funds should be insufficient, immediately contact our associate, Lisa Zumwalt, at (703)415-0579, who will pay immediately to avoid deprivation of rights.

&lt;&gt; Please charge my Deposit Account No.11-0224 in the amount of \$ \_\_\_\_\_. A duplicate copy of this sheet is enclosed.

A signature or signatures required for the above recited document(s) is (are) provided here below. Such signature(s) also provide(s) ratification for any required signature appearing to be authentic in the above recited document(s).

  
Horst M. Kasper, 13 Forest Drive, Warren, N.J. 07059  
Reg. No. 28,559 Tel.(908) 526-1717Certification of facsimile transmission:I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office, telefax number 571 273 1462, on APR 02 2008Signature: Date: APR 02 2008

\*\*Pat19:transT(HMP201T1)April 2, 2008(am)